

oplicant(s)

Juergen Engelbrechet

Serial No.

09/455,651

For

ADHESIVE SYSTEM FOR SILICONES

Filed

December 7, 1999

Examiner

Paul R. Michl

Art Unit

1714

745 Fifth Avenue New York, NY 10151

TECHNOLOGY CENTER 1700

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents Washington, DC 20231, on August 5, 2002.

Rohald R. Santucci, Reg. No. 28,988

Nome of Applicant Accionds or Desistered Denrescentative

Signature

August 5, 2002

Date of Signature

## AMENDMENT PURSUANT TO 37 C.F.R. 1.111 WITH REQUESTS FOR EXTENSION OF TIME AND INTERVIEW

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

This is responsive to the Office Action mailed on March 8, 2002. Any fee occasioned by this paper may be charged, or overpayment credited, to Deposit Account No. 50-0320.

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